

**Reply Under 37 CFR 1.116 - Expedited Procedure - Technology Center 2800**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 53080
	:	
Takeshi KOBAYASHI, et al.	:	Confirmation Number: 4950
	:	
Application No.: 10/757,388	:	Group Art Unit: 2893
	:	
Filed: January 15, 2004	:	Examiner: Dilinh P. Nguyen
	:	
For: LEAD FRAME, METHOD OF MANUFACTURING THE SAME, SEMICONDUCTOR DEVICE USING LEAD FRAME AND METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE	:	

**AMENDMENT UNDER 37 C.F.R. 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action dated June 16, 2009, having a three-month shortened statutory period for response set to expire on September 16, 2009, reconsideration of the above-identified application is respectfully requested in view of the following amendment and remarks.